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Thin films of AgIn₅(S/Se)₈ prepared in a two stage process

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Abstract $AgIn_5(S/Se)_8$ thin films were prepared by sequential chemical deposition of In_2S_3 - Ag_2Se stack films and post-deposition thermal annealing in N₂ atmosphere. The formations of $AgIn_5S_{8-x}Se_x$ alloy was achievable through the post-deposition treatment at 350 and 400 °C. X-ray diffraction and energy dispersive X-ray analyses were performed on the samples. The direct optical band gap value E_g for the films was found to be as the order of 1.75 eV at room temperature. The photo-response measurements exhibited that $AgIn_5(S/Se)_8$ thin films are photoconductive and p-type electrical conductivity of 6.6×10^{-6} (Ω cm)⁻¹ and thermoelectric power of +18 μ V/K.

1 Introduction

Chalcogenide ternary films of indium and silver have been reported with applications in optoelectronics and electronics devices [1-3]. Additionally, photovoltaic structure using AgIn₅S₈ has been obtained [2]. Furthermore, ternary AgIn₅Se₈ compound is an appropriate candidate for thermoelectric materials with many applications in the

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conversion of thermal energy to electrical power [4, 5]. Moreover, metal chalcogenide semiconductors are promising as visible-light-driven photocatalysts. In view of this fact, $AgIn_5S_8$ displays high activity for the evolution of hydrogen [6].

AgIn₅S₈ has been obtained by different techniques such as thermal evaporation in one stage using AgIn₅S₈ single crystals as a source material [1], or two stages using thermal evaporation of precursor metals and sulfurization [7], microwave hydrothermal synthesis [8], pulsed laser deposition [9], growth solution techniques as chemical deposition [10, 11], one-pot synthesis [12] and low-temperature water bath deposition process to obtain AgIn₅S₈ nanocomposite [13]. AgIn₅Se₈ has been synthetized from the elementary components at 1200 K in a quartz evacuated ampoule and subsequently annealed at 820 K for 300 h [14]. Alloys of AgIn₅S_{8-x}Se_x have been prepared by sintering stoichiometric mixtures of the binary compounds Ag₂S and Ag₂Se disposed at 773 K from the elements; and In₂S₃ and In₂Se₃ disposed at 1073 K from the elements, in evacuated and sealed silica ampoules at 1073 K and heated for 72 h at 1073 K [15]. Yiyun et al. [4] obtained a single phase of AgIn₅Se₈ by spark plasma sintering technique. Among the above mentioned methods, chemical bath deposition (CBD) is well known as a viable process to obtain large area and high quality semiconductor thin films with the advantages of simply, low cost and low energy consumption [16].

AgIn₅S₈ has been reported with *n*-type electrical conductivity and direct band gap of about 1.7 eV [17]. Vacuum evaporated AgIn₅S₈ thin films annealed in nitrogen at 450 and 600 K display energy band gap of 1.74 and 1.78 eV, respectively [18]. Qasrawi [19] obtained polycrystalline cubic AgIn₅S₈ samples, which exhibit direct allowed transitions and band gap energy of

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1.78 eV. Photoconductivity of the as-grown and nitrogen heat-treated AgIn₅S₈ films displays two recombination centers located at 66 and 16 meV [20]. Effects of temperature on the fundamental absorption edge produce a shift of the energy band gap from 1.78 to 1.73 eV as temperature boosts from 300 to 450 K. What is more, the fundamental absorption edge exhibited a temperature coefficient of -3.56×10^{-4} eV/K [21]. The carrier density of thermally deposited AgIn₅S₈ thin films increases from 1.74×10^{16} to 2.80×10^{19} cm⁻³ as the annealing temperature is raised from 350 to 450 K; and the Hall mobility decreases from a value of 16.7 cm² V⁻¹ s⁻¹ at 350 K to 6.9 cm² V⁻¹ s⁻¹ at 450 K [22]. Also, conductivity activation energies of 155 and 78 meV, in the temperature regions of 230-300 K and 90-220 K, respectively; and a density of localized states of 1.17×10^{20} cm⁻³ eV⁻¹, were reported [23]. On the other hand, previous work on ternary AgIn₅Se₈ compound and AgIn₅S₈–AgIn₅Se₈ system have been focused in structural and compositional analysis [4, 14, 15]. Seebeck coefficients for spark plasma sintering AgIn₅Se₈ are negative, which indicates that the majority of charge carriers are electrons (*n*-type) [5]. In addition to this, single phase of AgIn₅Se₈ displays a band gap of 1.11 eV [4, 5], whereas 1.22 eV is reported for Ag₃In₅Se₉ [17].

For this study, we have synthesized $AgIn_5(S/Se)_8$ thin films on corning glass substrates using a two stage process which consist on sequential chemical deposition of In_2S_3 and Ag_2Se films, followed by thermal annealing in nitrogen atmosphere at 350 and 400 °C. Thin film formation was determined by X-ray diffraction (XRD). Compositional, optical and electrical properties of such thin films are also analyzed in this work.

2 Experimental details

2.1 Thin films deposition

2.1.1 In_2S_3 thin films

In₂S₃ thin films were obtained by CBD following the method previously reported by Lugo et al. [13] but changing the indium source. Reaction solution in this work was carried out using the following chemical reagents in the order described here: 10 mL of InCl₃ 0.1 M, 2 mL of CH₃COOH 0.1 M, 16 mL of CH₃CSNH₂ 1 M, and water to complete a volume of 100 mL. Glass substrates (Corning, 25 mm \times 75 mm) were placed vertically into the beaker. Chemical deposition was carried out at 35 °C for 20 h, with this conditions the thickness of the films is 240 nm.

2.1.2 Ag_2Se thin films

Ag₂Se thin films were prepared using a reaction solution consisted on dissolving 100 mg of AgNO₃ in 10 mL water. Then 4 mL of 7.5 M of ammonia (aq.), 81 mL of deionized water and 5 mL of 0.1 M solution of Na₂SeSO₃ were mixed as described in [24]. Ag₂Se thin films were deposited at 10 °C during 30 min, the thickness of the films is (40 ± 3) nm.

2.1.3 In₂S₃-Ag₂Se stacking process

In₂S₃-Ag₂Se stacks were obtained by using sequential chemical bath of In₂S₃ and Ag₂Se. Ag₂Se thin films were deposited onto previously grown In₂S₃ layers. First, In₂S₃ thin films were grown on glass substrate as stated before. Subsequently, In₂S₃ films were immersed vertically into the beaker containing the solution to produce Ag₂Se thin films. The Ag₂Se deposition was carried out under the condition (time and temperature) mentioned above. Hence, In₂S₃-Ag₂Se stacks were obtained.

2.2 Heat treatment

The In₂S₃–Ag₂Se stack films were enveloped in Al foil and, subsequently, annealed in 1 Torr nitrogen atmosphere at 350 and 400 °C during 1 h, using a vacuum oven MTI-VBF-1200X. Film thickness measurements for In₂S₃– Ag₂Se thin films after heating resulted as (270 ± 14) nm.

3 Characterization

X-ray diffraction (XRD) patterns were recorded on a Rigaku Ultima IV diffractometer with Cu-Ka (1.5406 Å) radiation making grazing incidence of 1.0° with the sample plane. Such grazing incidence XRD (GIXRD) study helps to assess the structure and composition of the film along its thickness. An Oxford X-act energy dispersive X-ray spectrum (EDX) analyzer attached to a Hitachi-SEM SU1510 is used to analyze the chemical composition of the films. Optical transmittance (T) and specular reflectance (R) spectra of the films were recorded for film-side incidence with air and a front aluminized mirror as references on a UV-VIS-NIR V-670 JASCO spectrophotometer. The measured T and R data were used to evaluate the optical absorption coefficients (α) by considering multiple reflections within the thin film [25]. Pairs of silver-print electrodes 5 mm long at 5 mm separation applied on the film surface and dried at 60 °C for 30 min are used as contacts for the electrical characterization of the films. Keithley 230 programmable voltage source and Keithley 619 electrometer were utilized to study the photocurrent response of the films produced to different heat treatments. Each sample was stabilized in the dark in the measurement chamber. With a

bias (V) of 100 V across the electrodes (established previously as ohmic region), the current (I) in the sample was recorded at each 0.5 s for the first 20 s in the dark, the next 20 s under illumination and for the last 20 s after switching off the illumination. A tungsten-halogen ELH lamp provides an intensity of 1000 W/m² on the plane of the film. Electrical conductivity (σ) of the material of the different films is estimated from the current and voltage values, the electrode geometry and the film thickness. Films thickness was measured using an XP-200 Ambios Technology perfilometer. The Seebeck voltage was measured by a microvoltmeter/Scanning thermometer Keithley 740, and the DC Power supply with two Peltier elements to establish a difference of temperature. This measurement was used to determined conductivity type of the films.

4 Results and discussion

4.1 Structural properties

Figure 1 shows XRD patterns of In_2S_3 thin films annealed in N₂ at (a) 350 °C and (b) 400 °C. We have observed in both films that XRD peaks remain in the same position as that in the standard powder pattern JCPDS- 01074-7284 corresponding to In_2S_3 of tetragonal structure with lattice parameter values a = 7.6172 Å; b = 7.6172 Å; and c = 32.3307 Å, so the increment in temperature from 350 to 400 °C does not suggest any structural transition.

Thermal annealing of In₂S₃-Ag₂Se stack films at 350 and 400 °C during 1 h produces a solid state reaction with the formation of the AgIn₅(S/Se)₈ thin film as XRD patterns in Fig. 2a, b shown. The diffractogram shows XRD peaks matching well with the standard pattern of cubic AgIn₅S₈ with cell parameter a = 10.825 Å (JCPDS-26-1477) and tetragonal AgIn₅Se₈ with cell parameter a = 5.7740 Å, b = 5.7740 Å and c = 11.6100 Å (JCPDS 26-1471). Diffraction peaks at $2\theta = 14.2^{\circ}$, 23.2° , 33.1° , 44.1° and 47.7° match with (111), (220), (311), (400), (511) and (440) planes from AgIn₅S₈ standard, respectively. On the other hand, the peaks at $2\theta = 26.83$, 38.1and 44.37 match with (112), (202) and (220) planes from AgIn₅Se₈ standard, respectively. Peak at $2\theta = 24.9^{\circ}$ is associated with (110) plane of In₂Se₃ (JCPDS- 00-023-0294). XRD peaks remain unchanged with the increase in annealing temperature and, hence, we established 350 °C as a proper temperature to obtain the ternary compound. To estimate the value of x in the $AgIn_2S_{8-x}Se_x$ alloy, we follow a method previously reported in Ref. [26] in which it is assumed a linear variation of inter-planar spacing d for the solid solution $Sb_2S_xSe_{3-x}$. This leads to the designation of the thin film in the cell structure as $AgIn_5S_{7,8}Se_{0,2}$.



Fig. 1 XRD patters of $\rm In_2S_3$ thin films heated at 350 and 400 $^{\circ}\rm C$

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4.2 Chemical composition

The characteristic peaks of In-L_{α} at 3.286 keV and S-K_{α} at 2.307 keV; or In-L_{α} at 3.286 keV, Ag-L_{α} at 2.98 keV, Se-L_{α} at 1.379 keV and S-K_{α} at 2.307 keV are identified in the EDX spectra of In₂S₃ films or In₂S₃-Ag₂Se stack films annealed at 350 °C, along with Si-K_{α} at 1.74 keV arising from the substrate. Figure 3 shows the EDX spectrum of AgIn₅(S/Se)₈ thin film. The composition of In₂S₃ films correspond to weight percentage of: In = 72.9 % and S = 27.1 %. This result indicated that the composition of the film is close to the stoichiometric formula of In₂S₃, where In:S ratio is 2:3. Thin films of AgIn₅(S/Se)₈ present the following results: Ag = 16.4 %, In = 59.9 %, S = 20.6 % and Se = 2.9 %. Such S-rich films are in agreement with the results reported by Haeuseler and coworker on the system $AgIn_5S_{8-x}Se_x$ (0 < x < 8), where 11 different compositions were found [15]. Thus, according to XRD and EDX results, we propose that the solid state reaction produced by the thermal annealing of In₂S₃-Ag₂Se stack films results on the formation of AgIn₅S_{7.8}Se_{0.2} alloy thin films. EDX analyses show that chemical composition is homogeny along the samples. The errors in the data were evaluated to be about 5 %.



Fig. 3 EDX spectrum of In₂S₃-Ag₂Se thin films heated at 350 °C

4.3 Optical properties

Optical properties were recorded in the range between 250 and 2500 nm. Figure 4 illustrates the optical transmittance (*T*) and the specular reflectance (*R*) for In_2S_3 and In_2S_3 -Ag₂Se thin films heated at 350 °C.



Fig. 4 Transmittance (*T*) and reflectance (*R*) spectra for In_2S_3 and $AgIn_5(S/Se)_8$ samples after heating at 350 °C

Optical absorption coefficient (α) as a function of the photon energy (hv) was estimated from the transmittance (T) and reflectance (R) spectra data; and film thickness (d) measurements according to the following equation [25]:

$$\alpha = \frac{1}{d} ln \left\{ \frac{(1-R)^2}{2T} + \left[\left(\frac{(1-R)^2}{2T} \right)^2 + R^2 \right]^{\frac{1}{2}} \right\}$$
(1)

The band gap (E_g) was calculated using the relationship: $\alpha hv = A(hv - Eg)^n$ (2)

Fig. 5 Optical band gap for a In_2S_3 and b $AgIn_5(S/Se)_8$ thin films

were A is a constant as a function of the transition probability.

Plot of $(\alpha hv)^{2/3}$ versus hv was used to calculate the value of energy band gap by adjusting the linear part of the curve, as shown in Fig. 5a. Straight line region in this plot indicates that the absorption edge corresponds to a direct forbidden electronic transition. The value of E_g was obtained when the adjusting line tends to zero. For In₂S₃ layer heated at 350 °C $E_g = (2.4 \pm 0.4)$ eV, which corresponds to that value reported in literature for In₂S₃ thin films [27].

Plot of $(\alpha h\nu)^{2/3}$ versus $h\nu$ is given in Fig. 5b for AgIn₅(S/Se)₈ thin film. The energy band gap E_g was calculated according to the Eq. (2). The linearity of plot $(\alpha h\nu)^{2/3}$ versus $h\nu$ indicates that the absorption edge corresponds to a direct forbidden transition. The E_g value obtained was (1.75 ± 0.6) eV. Only values for the AgIn₅S₈ (1.74-1.78 eV) and AgIn₅Se₈ (1.1 eV) has been reported previously [4, 5, 11, 18, 19]. We suggest that the band gap value is close to the AgIn₅S₈ because the small quantity of selenium; in agreement with XRD and EDX results. The values of the optical absorption coefficient, $\alpha > 10^4$ cm⁻¹, in addition to the optical band gap value allow us to consider the AgIn₅(S/Se)₈ film as a promising candidate for solar cell applications.

4.4 Electrical properties

Photo-response measurements of In_2S_3 and In_2S_3 -Ag₂Se thin films annealed at 350 °C in N₂ are given in Fig. 6. The







electrical conductivity of In₂S₃ thin films heating at 350 °C is $\sigma_{dark}=3.7\,\times\,10^{-8}\,(\Omega~cm)^{-1}$, when the film is heated at 400 °C the conductivity is at the same order of magnitude as shown in Fig. 6a, this result is in agreement with the value reported previously for thin films by chemical deposition [28]. The In₂S₃-Ag₂Se thin films annealing at 350 °C exhibit a value of $\sigma_{dark} = 6.6\,\times\,10^{-6}\,(\Omega~cm)^{-1}$ that is very similar to the stack films heating at 400 °C, as observed in Fig. 6b. This value is more than two orders of magnitude higher than In_2S_3 thin films, as expected, due to silver and selenide incorporation in the formation of AgIn₅(S/Se)₈. Thin films of In₂S₃ heated at 350 °C shows a value of photoconductivity (σ_{ph}) of 6.8 × 10⁻⁸ (Ω cm)⁻¹. Additionally, AgIn₅(S/Se)₈ presents a value of σ_{ph} of 2.5 × 10⁻⁴ $(\Omega \text{ cm})^{-1}$, two orders of magnitude higher than in the dark. The errors in the data were evaluated to be 2-5 %.

The thermoelectric potential (V) at the cold end with respect to the hot end of the semiconductor subjected to a temperature difference ΔT was measured. Figure 7 shows the result for AgIn₅(S/Se)₈ alloy produced from In₂S₃– Ag₂Se stack films heated at 400 °C. The value of Seebeck coefficient is +(18.7 ± 0.9) μ V/K, so that suggesting that the film is slightly of p-type conductivityMaterials can be obtained either p-type or n-type, depending on growth conditions, stoichiometry and post-deposition thermal annealing. For instance, AgInSe₂ shows both n-type and p-type conductivity depending on particular growth conditions [29]. AgInSe₂ p-type films have been obtained by post-deposition thermal annealing under selenium atmosphere [30]. On the other hand, AgIn₅S₈ and AgIn₅Se₈ have been reported in the literature with n-type conductivity



Fig. 7 Thermoelectric potential (V) versus temperature difference (Δ T) of AgIn₅(S/Se)₈ produced from In₂S₃-Ag₂Se stack films heated at 400 °C

[5, 17]. In this work we reported a new methodology for the formation of $AgIn_5(S/Se)_8$ with p-type conductivity. We suggest that the incorporation of selenium in $AgIn_5(S/Se)_8$ samples might be seen as a similar process to the postdeposition annealing under Se pressure in $AgInSe_2$ films [30]. The incorporation of selenium may lead to the formation of interstitial intrinsic defects that contribute to the p-type conductivity. P-type conductivity is desired for the absorber layer because of the heterojunction partner availability and the longer minority carrier diffusion length of electrons.

5 Conclusions

The films of AgIn₅(S/Se)₈ were obtained on glass substrates by annealing at 350–400 °C in nitrogen atmosphere chemically deposited In₂S₃–Ag₂Se stack films. The formation of the AgIn₅S_{7.8}Se_{0.2} has been established on the basis of XRD and EDX results. The films have direct optical band gap of 1.75 eV and optical absorption coefficient of 10⁴ cm⁻¹. Samples are photoconductive with p-type electrical conductivity (in dark) of 6.6×10^{-6} (Ω cm)⁻¹. The Seebeck effect shows a value of +18 μ V/K. The optical band gap, electrical conductivity and the photoconductivity of these materials fulfil the basic requirements for their integration into photovoltaic structures.

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References

- 1. A.F. Qasrawi, T.S. Kayed, I. Ercan, Mater. Sci. Eng. B 113, 73 (2004)
- I. Konovalov, L. Makhova, R. Hesse, R. Szargan, Thin Solid Films 493, 282 (2005)
- L. Makhova, I. Konovalov, R. Szargan, Phys. Status Solidi A 201, 308 (2004)
- L. Yiyun, M. Qingsen, C. Jiaolin, S. Weiwei, G. Yulan, Procedia Eng. 27, 151 (2012)
- J.L. Cui, Y.Y. Li, Y. Deng, Q.S. Meng, Y.L. Gao, H. Zhou, Y.P. Li, Intermetallics **31**, 217 (2012)
- 6. D. Chen, J. Ye, J. Phys. Chem. Solids 68(12), 2317 (2007)
- L. Makhova, R. Szargan, I. Konovalov, Thin Solid Films 472, 157 (2005)

- Z. Wenjuan, L. Danzhen, S. Meng, S. Yu, C. Zhixin, X. Guangcan, F. Xianzhi, J. Solid State Chem. 183, 2466 (2010)
- 9. I.V. Bodnar, V.F. Gremenok, Thin Solid Films 487, 31 (2005)
- C. Kong-Wei, H. Chao-Ming, P. Guan-Ting, C. Wen-Sheng, L. Tai-Chou, C.K. Yang, J. Photochem. Photobiol. A **190**, 77 (2007)
- C. Kong-Wei, W. Sheng-Chih, Sol. Energy Mater. Sol. Cells 93, 307 (2009)
- L. Xiangqing, W. Lei, W. Dailong, K. Shizhao, M. Jin, Mater. Res. Bull. 48, 286 (2013)
- S. Lugo, Y. Peña, M. Calixto-Rodriguez, C. López-Mata, M.L. Ramón, I. Gómeza, A. Acosta, Appl. Surf. Sci. 263, 440 (2012)
- I.A. Ivashchenko, L.D. Gulay, O.F. Zmiy, I.D. Olekseyuk, J. Alloys Compd. 427, 101 (2007)
- H. Haeuseler, E. Elitok, A. Memo, A. Osnowsky, Mater. Res. Bull. 36, 737 (2001)
- G. Hodes, Chemically Solution Deposition of Semiconductor Films, 1er edn. (Marcel Dekker Inc., New York, 2003), pp. 32–33
- O. Madelung, Semiconductors Other than Group IV Elements and III-V Compounds, 1er edn. (Springer, Berlin, 1992), pp. 50–52
- 18. A.F. Qasrawi, J. Alloys Compd. 455, 295 (2008)
- 19. A.F. Qasrawi, Thin Solid Films **516**, 1116 (2008)
- A.F. Qasrawi, T.S. Kayed, E. Ismail, J. Alloys Compd. 508, 380 (2010)
- 21. A.F. Qasrawi, Thin Solid Films 519, 3768 (2011)
- A.F. Qasrawi, T.S. Kayed, E. Filiz, Solid State Commun. 151, 615 (2011)
- 23. A.F. Qasrawi, Thin Solid Films 519, 6583 (2011)
- K. Bindu, M.T.S. Nair, T.K. Das Roy, P.K. Nair, Electrochem. Solid State Lett. 6, G195 (2006)
- 25. D.K. Schroder, Semiconductor Materials and Device Characterization, 2nd edn. (Wiley, New York, 1990), pp. 596–597
- M. Calixto-Rodriguez, H. Moreno-García, M.T.S. Nair, P.K. Nair, J. Solid State Sci. Technol. 2, Q69 (2013)
- M.G. Sandoval-Paz, M. Sotelo-Lerma, J.J. Valenzuela-Jauregui, M. Flores-Acosta, R. Ramírez-Bon, Thin Solid Films 472, 5 (2005)
- S. Lugo-Loredo, Y. Peña-Méndez, M. Calixto-Rodriguez, S. Messina-Fernández, A. Alvarez-Gallegos, A. Vázquez-Dimas, T. Hernández-García, Thin Solid Films 550, 110 (2014)
- D. Abdel-Hady, A.M. Salem, Phys. A Stat. Theor. Phys. 242, 141 (1997)
- 30. K. Yoshino, Phys. B Condens. Matter 302, 349 (2001)